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APPLICANTS  Seok-Woo Lee, Seoul, KOREA, REPUBLIC OF;  <i>NONE MC</i> ** CONTINUING DATA *****  <i>OK MC</i> ** FOREIGN APPLICATIONS ***** REPUBLIC OF KOREA 2002-067120 10/31/2002  IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 01/29/2004					
Foreign Priority claimed 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no Verified and Acknowledged <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>Morgan Lewis</i> Examiner's Signature <i>MC</i> Initials		STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 9	TOTAL CLAIMS 12	INDEPENDENT CLAIMS 1
ADDRESS 009629 MORGAN LEWIS & BOCKIUS LLP 1111 PENNSYLVANIA AVENUE NW WASHINGTON , DC 20004					
TITLE Method of forming polysilicon thin film transistor					
FILING FEE  RECEIVED 770	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		